Amendments to the Claims:

The following listing of claims will replace all prior versions, and listings, of claims in the application:

- 1-30. (Canceled)
- 31. (Currently Amended) An exposure method in which an exposure processing of a specific process is performed to each of a plurality of photosensitive objects, said method comprising:

a first process in which estimate values of positional information used to align each of a plurality of divided areas on a photosensitive object with a predetermined point are calculated by a statistical computation, using actual measurement values of positional information of a plurality of specific divided areas selected from said plurality of divided areas on said photosensitive object; and

a second process in which which, with respect to a plurality of measurement divided areas on said photosensitive object including at least said plurality of specific divided areas,

a non-linear component of positional deviation amount from an individual fiducial position of each of said plurality of measurement divided areas is calculated respectively at predetermined intervals, based on an actual measurement value of positional information of each of said plurality of measurement divided areas and on each of said estimate values, values, said predetermined intervals being one of intervals of a predetermined period of time; and

judgment is made about the necessity of update of updating correction information based on magnitude of one of

said non-linear component of positional deviation amount calculated of

each of said plurality of measurement divided areas areas, and

a variation amount of the non-linear component, said correction information being used to correct a non-linear component of positional deviation amount from an individual fiducial position of each of said plurality of divided areas on said photosensitive object.

32. (Currently Amended) The exposure method of Claim 31, further comprising:
a third process in which an update processing to update said correction
information is performed when it is judged that update is necessary in said second process;
and

a fourth process in which exposure is performed controlling a position of said photosensitive object based on the estimate value of positional information of each of said plurality of divided areas and said correction information that is latest.

33. (Previously Presented) The exposure method of Claim 32 wherein in said third process, when the update processing of said correction information is performed,

among said plurality of divided areas, at least a part of remaining divided areas excluding said plurality of measurement divided areas are to be new measurement divided areas, and

said correction information is updated using a non-linear component of positional deviation amount from said individual fiducial position of each of said plurality of divided areas calculated based on actual measurement values of positional information of all measurement divided areas including the new measurement divided areas and on said estimate values.

34. (Previously Presented) The exposure method of Claim 33 wherein

said new measurement divided areas are determined based on evaluation results of said non-linear component of positional deviation amount of each of said plurality of divided areas included in said correction information before update.

- 35. (Previously Presented) The exposure method of Claim 33 wherein said new measurement divided areas are determined based on evaluation results of one of said non-linear component of positional deviation amount of each of said plurality of measurement divided areas calculated in said second process and a variation amount of the non-linear component.
 - 36. (Cancelled)
- 37. (Previously Presented) The exposure method of Claim 31 wherein as said plurality of measurement divided areas on said photosensitive object, only said plurality of specific divided areas can be designated.
- 38. (Previously Presented) The exposure method of Claim 31 wherein as said plurality of measurement divided areas on said photosensitive object, at least a part of remaining divided areas can be designated in addition to said plurality of specific divided areas.
- 39. (Previously Presented) The exposure method of Claim 31 wherein said correction information is one of a correction map and a correction function.
- 40. (Currently Amended) A device manufacturing method including a lithographic process wherein

in said lithographic process, an exposure processing of a specific process is continuously or intermittently performed to each of a plurality of photosensitive objects using the exposure method of Claim 1. Claim 31.

41. (Currently Amended) An exposure method in which an exposure processing of a specific process is performed to each of a plurality of photosensitive objects, said method comprising:

a process in which estimate values of positional information used to align each of a plurality of divided areas on a photosensitive object with a predetermined point are calculated by a statistical computation, using actual measurement values of positional information of a plurality of specific divided areas selected from said plurality of divided areas on said photosensitive object;

a process in which which, with respect to a plurality of measurement divided areas on said photosensitive object including at least said plurality of specific divided areas,

a non-linear component of positional deviation amount from an individual fiducial position of each of said plurality of measurement divided areas obtained from each actual measurement value of positional information and each of said estimate values is evaluated at predetermined intervals, said intervals are one of intervals of a predetermined number of said photosensitive objects and intervals of a predetermined period of time, and

at least one of the <u>a</u> number of new measurement divided areas to be added and an arrangement thereof is determined based on the evaluation results;

a process in which correction information related to a non-linear component of positional deviation amount from an individual fiducial position of each of said plurality of divided areas on said photosensitive object is updated, using said non-linear component of positional deviation amount of each of said plurality of divided areas on said photosensitive object, said non-linear component of positional deviation amount being calculated based on actual measurement values of positional information of all measurement divided areas including said new measurement divided areas and on said estimate values; and

a process in which exposure is performed controlling a position of said photosensitive object based on the estimate value of positional information of each of said plurality of divided areas and said correction information after update.

- 42. (Previously Presented) The exposure method of Claim 41 wherein the evaluation of said non-linear component of positional deviation amount of each of said plurality of measurement divided areas is performed, taking into consideration at least one of magnitude and a dispersion degree of said non-linear component of positional deviation amount of each of said plurality of measurement divided areas in said correction information before update.
- 43. (Previously Presented) The exposure method of Claim 41 wherein the evaluation of said non-linear component of positional deviation amount of each of said plurality of measurement divided areas is performed, using a predetermined evaluation function.
- 44. (Previously Presented) The exposure method of Claim 41 wherein said plurality of divided areas on said photosensitive object are grouped into a plurality of blocks in advance, and

the evaluation of said non-linear component of positional deviation amount of each of said plurality of measurement divided areas is performed with respect to each block.

- 45. (Cancelled)
- 46. (Previously Presented) The exposure method of Claim 41 wherein as said plurality of measurement divided areas on said photosensitive object, only said plurality of specific divided areas can be designated.
- 47. (Previously Presented) The exposure method of Claim 41 wherein as said plurality of measurement divided areas on said photosensitive object, at least a part of remaining divided areas can be designated in addition to said plurality of

specific divided areas.

- 48. (Previously Presented) The exposure method of Claim 41 wherein said correction information is one of a correction map and a correction function.
- 49. (Previously Presented) A device manufacturing method including a lithographic process wherein

in said lithographic process, an exposure processing of a specific process is continuously or intermittently performed to each of a plurality of photosensitive objects using the exposure method of Claim 41.

50. (Currently Amended) An exposure apparatus that performs an exposure processing of a specific process to each of a plurality of photosensitive objects, said apparatus comprising:

a moving body that holds a photosensitive object;

a detection system that detects actual measurement values of positional information of any divided areas among a plurality of divided areas on said photosensitive object held on said moving body;

a computation unit that calculates estimate values of positional information used to align each of said plurality of divided areas with a predetermined point by a statistical computation, using actual measurement values of positional information of a plurality of specific divided areas among said plurality of divided areas on said photosensitive object detected by said detection system;

a judgment unit that that, with respect to a plurality of measurement divided areas on said photosensitive object including at least said plurality of specific divided areas,

calculates a non-linear component of positional deviation amount from an individual fiducial position of each of said plurality of measurement divided areas

respectively at predetermined intervals, based on an actual measurement value of positional information of each of said plurality of measurement divided areas detected by said detection system and each of said estimate values of positional information calculated by said computation unit, said intervals are one of intervals of a predetermined number of said photosensitive objects and intervals of a predetermined period of time, and

judges the necessity of update of updating correction information based on magnitude of one of said non-linear component of positional deviation amount calculated of for each of said plurality of measurement divided areas and a variation amount of the non-linear component, said correction information being used to correct a non-linear component of positional deviation amount from an individual fiducial position of each of said plurality of divided areas on said photosensitive object;

an updating unit that performs a processing to update said correction information when said judgment unit judges that update is necessary; and

a control unit that controls a position of said photosensitive object via said moving body based on the estimate value of positional information of each of said plurality of divided areas and said correction information that is latest, when exposing each of said plurality of divided areas.

51. (Previously Presented) The exposure apparatus of Claim 50 wherein said updating unit comprises:

a determining unit that determines at least a part of remaining divided areas excluding said plurality of measurement divided areas among said plurality of divided areas on said photosensitive object, as new measurement divided areas; and

a calculating unit that calculates a non-linear component of positional deviation amount from said individual fiducial position of each of said plurality of divided areas on said photosensitive object as new correction information, based on actual

measurement values of positional information of all measurement divided areas including actual measurement values of positional information of the new measurement divided areas detected by said detection system and on said estimate values.

- 52. (Currently Amended) The exposure apparatus of Claim 51 wherein said determining unit determines said new measurement divide divided areas based on evaluation results of one of said non-linear component of positional deviation amount of each of said plurality of measurement divided areas calculated by said judgment unit and a variation amount of the non-linear component.
 - 53. (Cancelled)
- 54. (Previously Presented) The exposure apparatus of Claim 50, wherein a first mode in which only said plurality of specific divided areas are designated as said plurality of measurement divided areas on said photosensitive object, and a second mode in which said plurality of specific divided areas and at least a part of remaining divided areas are designated as said plurality of measurement divided areas on said photosensitive object are settable.
- 55. (Previously Presented) The exposure apparatus of Claim 50 wherein said correction information is one of a correction map and a correction function.
- 56. (Currently Amended) An exposure apparatus that performs an exposure processing of a specific process to each of a plurality of photosensitive objects, said apparatus comprising:

a moving body that holds a photosensitive object;

a detection system that detects actual measurement values of positional information of any divided areas on said photosensitive object held on said moving body;

a computation unit that calculates estimate values of positional information used to align each of a plurality of divided areas with a predetermined point by a statistical computation, using actual measurement values of positional information of a plurality of specific divided areas among said plurality of divided areas on said photosensitive object detected by said detection system;

an evaluation unit that that, with respect to a plurality of measurement divided areas on said photosensitive object including at least said plurality of specific divided areas,

evaluates a non-linear component of positional deviation amount from an individual fiducial position of each of said plurality of measurement divided areas at predetermined intervals, based on an actual measurement value of positional information of each of said plurality of measurement divided areas detected by said detection system and each of said estimate values of positional information calculated by said computation unit, said predetermined intervals being one of intervals of a predetermined number of said photosensitive objects and intervals of a predetermined period of time, and

determines at least one of the number of new measurement divided areas to be added and an arrangement thereof, based on the evaluation results;

an updating unit that updates correction information related to a non-linear component of positional deviation amount from an individual fiducial position of each of said plurality of divided areas on said photosensitive object, using said non-linear component of positional deviation amount of each of said plurality of divided areas on said photosensitive object, said non-linear component of positional deviation amount being calculated based on actual measurement values of positional information of all measurement divided areas including actual measurement values of positional information of the new measurement divided areas detected by said detection system and on said estimate values; and

a control unit that controls a position of said photosensitive object via said moving body based on the estimate value of positional information of each of said plurality of divided areas calculated by said computation unit and said correction information that is latest, when exposing each of said plurality of divided areas.

57. (Previously Presented) The exposure apparatus of Claim 56 wherein said plurality of divided areas on said photosensitive object are grouped into a plurality of blocks in advance, and

said evaluation unit performs the evaluation of said non-linear component of positional deviation amount of each of said plurality of measurement divided areas with respect to each block.

- 58. (Cancelled)
- 59. (Previously Presented) The exposure apparatus of Claim 57, wherein a first mode in which only said plurality of specific divided areas are designated as said plurality of measurement divided areas on said photosensitive object, and a second mode in which said plurality of specific divided areas and at least a part of remaining divided areas are designated as said plurality of measurement divided areas on said photosensitive object are settable.
- 60. (Previously Presented) The exposure apparatus of Claim 56 wherein said correction information is one of a correction map and a correction function.
- 61. (Currently Amended) A <u>computer readable medium that stores a</u> program that makes a computer for control of an exposure apparatus that performs an exposure processing of a specific process to each of a plurality of photosensitive objects execute a predetermined processing, said program making said computer execute:

a procedure in which estimate values of positional information used to align each of a plurality of divided areas on a photosensitive object with a predetermined point are calculated by a statistical computation, using actual measurement values of positional information of a plurality of specific divided areas selected from said plurality of divided areas on said photosensitive object; and

a procedure in which which, with respect to a plurality of measurement divided areas on said photosensitive object including at least said plurality of specific divided areas,

a non-linear component of positional deviation amount from an individual fiducial position of each of said plurality of measurement divided areas is calculated respectively at predetermined intervals, based on an actual measurement value of positional information of each of said plurality of measurement divided areas and on each of said estimate values, said predetermined intervals being one of intervals of a predetermined number of said photosensitive objects and intervals of a predetermined period of time, and

judgment is made about the necessity of update of updating correction information based on magnitude of one of said non-linear component of positional deviation amount calculated of for each of said plurality of measurement divided areas and a variation amount of the non-linear component, said correction information being used to correct a non-linear component of positional deviation amount from an individual fiducial position of each of said plurality of divided areas on said photosensitive object.

62. (Currently Amended) A <u>computer readable medium that stores a</u> program that makes a computer for control of an exposure apparatus that performs an exposure processing of a specific process to each of a plurality of photosensitive objects execute a predetermined processing, said program making said computer execute:

a procedure in which estimate values of positional information used to align

each of a plurality of divided areas on a photosensitive object with a predetermined point are calculated by a statistical computation, using actual measurement values of positional information of a plurality of specific divided areas selected from said plurality of divided areas on said photosensitive object; and

a procedure in which which, with respect to a plurality of measurement divided areas on said photosensitive object including at least said plurality of specific divided areas,

a non-linear component of positional deviation amount from an individual fiducial position of each of said plurality of measurement divided areas obtained from each actual measurement value of positional information and each of said estimate values is evaluated at predetermined intervals, said predetermined intervals being one of intervals of a predetermined number of said photosensitive objects and intervals of a predetermined period of time, and

at least one of the number of new measurement divided areas to be added and an arrangement thereof is determined based on the evaluation results;

a procedure in which correction information related to a non-linear component of positional deviation amount from an individual fiducial position of each of said plurality of divided areas on said photosensitive object is updated, using said non-linear component of positional deviation amount of each of said plurality of divided areas on said photosensitive object, said non-linear component of positional deviation amount being calculated based on actual measurement values of positional information of all measurement divided areas including said new measurement divided areas and on said estimate values; and

a procedure in which exposure is performed controlling a position of said photosensitive object based on the estimate value of positional information of each of said plurality of divided areas and said correction information after update.